



## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
 United States Patent and Trademark Office  
 Address: COMMISSIONER FOR PATENTS  
 P.O. Box 1450  
 Alexandria, Virginia 22313-1450  
 www.uspto.gov

## \*BIBDATASHEET\*

CONFIRMATION NO. 5727

Bib Data Sheet

|                             |                                       |              |                        |                        |
|-----------------------------|---------------------------------------|--------------|------------------------|------------------------|
| SERIAL NUMBER<br>10/624,003 | FILING DATE<br>07/22/2003<br><br>RULE | CLASS<br>438 | GROUP ART UNIT<br>2829 | ATTORNEY<br>DOCKET NO. |
|-----------------------------|---------------------------------------|--------------|------------------------|------------------------|

## APPLICANTS

Steven Shuyong Xiao, Laval, CANADA;

Chunong Qiu, Brossard, CANADA;

Cindy Xing Qiu, Brossard, CANADA;

\*\* CONTINUING DATA \*\*\*\*\* None AICS

\*\* FOREIGN APPLICATIONS \*\*\*\*\* None AICS

IF REQUIRED, FOREIGN FILING LICENSE GRANTED \*\* SMALL ENTITY \*\*  
 \*\* 11/26/2003

|  |   |                               |                        |                       |                            |
|--|---|-------------------------------|------------------------|-----------------------|----------------------------|
| Foreign Priority claimed<br>35 USC 119 (a-d) conditions met<br>Verified and Acknowledged | <input type="checkbox"/> yes <input checked="" type="checkbox"/> no<br><input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance<br>Examiner's Signature: <i>ASR</i> Initials: <i>Carhar</i> | STATE OR<br>COUNTRY<br>CANADA | SHEETS<br>DRAWING<br>7 | TOTAL<br>CLAIMS<br>11 | INDEPENDENT<br>CLAIMS<br>1 |
|--|---|-------------------------------|------------------------|-----------------------|----------------------------|

## ADDRESS

AIR MAIL

Dr. Steven Shuyong Xiao  
 3455 Isabelle, Local E  
 Brossard, QC  
 J4Y 2R2  
 CANADA

## TITLE

Non-vacuum methods for the fabrication of organic semiconductor devices

|                                   |   |   |
|-----------------------------------|---|---|
| FILING FEE<br><br>RECEIVED<br>440 | FEES: Authority has been given in Paper<br>No. _____ to charge/credit DEPOSIT ACCOUNT<br>No. _____ for following: | <input type="checkbox"/> All Fees<br><input type="checkbox"/> 1.16 Fees ( Filing )<br><input type="checkbox"/> 1.17 Fees ( Processing Ext. of time )<br><input type="checkbox"/> 1.18 Fees ( Issue )<br><input type="checkbox"/> Other _____<br><input type="checkbox"/> Credit |
|-----------------------------------|---|---|